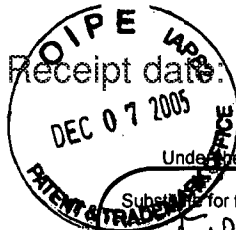


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Sheet	two	of	two	Application Number	10/539,429
				Filing Date	December 19, 2003
				First Named Inventor	Sébastien BRANGOULO
				Art Unit	
				Examiner Name	
				Attorney Docket Number	F2.12-3

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	AC	EGGER O ET AL: "High Compression Image Coding Using An Adaptive Morphological Subband Decomposition", Proceedings of the IEEE, Feb. 1, 1995, p. 272-287, Vol. 83, no. 2, IEEE	
	AD	HARIDASAN R ET AL: "Scalable Coding of Video Objects", Circuits and Systems, Proc. 1998 IEEE Int'l Symposium, May 31, 1998, p. 289-292, ISCAS '98, New York, NY	
	AE	DAVOINE F ET AL: "Adaptive Delaunay Triangulation for Attractor Image Coding", Pattern Recog., Computer Vision & Image, Proc. 12th IAPR Int'l Conf., Oct. 9, 1994, p. 801-803,	
	AJ	SWELDENS W: "The Lifting Scheme: A Construction of Second Generation Wavelets", SIAM Journal on Mathematical Analysis, Mar. 1998, p. 511-546, V. 29, no. 2.	
	AK	DAHMEN W: "Decomposition of Refinable Spaces And Applications To Operator Equations", Numerical Algorithms 5, 1993, p. 229-245.	
	AL	CARNICER J ET AL: "Local Decomposition of Refinable Spaces And Wavelets", Appl. Comp. Harm. Anal. 3, 1996, p. 127-153	
	AM	LOUNSBERY M ET AL: "Multiresolution Analysis for Surfaces of Arbitrary Topological Type", ACM Transactions on Graphics, Jan. 1997, V. 16, No. 1, p. 34-73 Univ. Washington	

Examiner Signature	/Chikaodili Anyikire/	Date Considered	08/25/2009
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